

Notice of References Cited	Application/Control No. 10/516,457		Applicant(s)/Patent Under Reexamination PUECH, MICHEL	
	Examiner Jeffrie R. Lund		Art Unit 1792	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,788,799 A	08-1998	Steger et al.	156/345.37
*	B	US-6,014,979 A	01-2000	Van Autry et al.	134/1.1
*	C	US-2002/0004309 A1	01-2002	COLLINS et al.	438/719
*	D	US-2002/0015855 A1	02-2002	Sajoto et al.	428/639
*	E	US-2002/0102858 A1	08-2002	Wicker et al.	438/731
*	F	US-6,518,195 B1	02-2003	Collins et al.	438/723
*	G	US-6,531,031 B1	03-2003	Becker et al.	156/345.48
*	H	US-2003/0213560 A1	11-2003	Wang et al.	156/345.31
*	I	US-2004/0140205 A1	07-2004	Fu et al.	204/298.2
*	J	US-2007/0062452 A1	03-2007	Pancham et al.	118/723.001
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U					
	V					
	W					
	X					

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.